



AF *AM*
Attorney Docket SEL 203 *AM 813*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
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NAKAJIMA et al.)
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Serial No.: 09/635,945)
)
Filed: August 10, 2000)
)
For: Semiconductor Device And Method)
Of Manufacturing The)
Semiconductor Device)
)
)
Art Unit: 2811)
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)
Examiner: S. Hu)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents , P.O. Box 1450, Alexandria, VA 22313-1450 on <u>February 9 2005</u> (Date of Deposit) <u>Shannon Wallace</u> Name of applicant, assignee, or Registered Rep. <u>Shannon Wallace</u> <u>2/9/05</u> Signature Date	
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by
RCE
3/7/05*

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT G (AFTER FINAL)

In response to the Final Rejection of November 10, 2004, please enter the following amendment in the above-identified application: